

Attorney Docket  
033773 M 013



FF6/9/8/04 P A T E N T

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

**Takahiro SAITO**

US Serial No.: 09/752,563

Filed: January 3, 2001

*W.M.Hart*  
Group Art Unit: 3724  
Examiner: C. Goodman

For: METHOD OF CUTTING CSP SUBSTRATES

**AMENDMENT**

Commissioner for Patents  
Washington, DC 20231

RECEIVED  
DEC 27 2002  
TECHNOLOGY CENTER R3700

Sir :

A response to the Office Action dated September 26, 2002 (Paper No. 3) is due by December 26, 2002. Therefore, please accept this Amendment as timely filed and fully responsive.

In response to Paper No. 3, kindly amend the above-identified patent application as follows:

**IN THE DRAWINGS:**

Pursuant to M.P.E.P. § 608.02(r), Applicant files with this Amendment, a Letter that describes a proposed change to original Fig. 1 in this application. Applicant respectfully requests the Examiner's and the Office Draftsperson's approval of this proposed change.